



UNITED STATES PATENT AND TRADEMARK OFFICE

Commissioner for Patents
United States Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450
www.uspto.gov

Paper No. 23

Date : March 23, 2004
TO : Director, Office of Patent Publication
FROM : Office of the Deputy Commissioner
for Patent Examination Policy
SUBJECT : Withdrawal from Issue of

Applicant(s) : Takashi Ipposhi, et al.
Application No. : 09/930,202
Filed : August 16, 2001

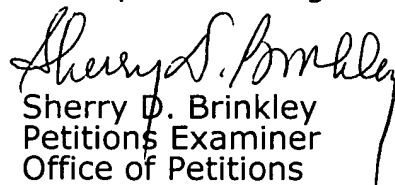
The above-identified application has been assigned Patent No. 6,717,239 and an issue date of April 6, 2004.

It is hereby directed that this application be withdrawn from issue at the request of the applicant.

Do not refund the issue fee.

The following erratum should be published in the Official Gazette if the above-identified application is published in the OG of April 6, 2004:

"All reference to Patent No. 6,717,239 to TAKASHI IPPOSHI, ET AL. of JAPAN for SEMICONDUCTOR WAFER appearing in the Official Gazette of April 6, 2004, should be deleted since no patent was granted."


Sherry D. Brinkley
Petitions Examiner
Office of Petitions
Office of the Deputy Commissioner
for Patent Examination Policy

cc: Geraldine Dozier, Crystal Park 3-441 (FAX-306-2737)
Deneise Boyd, Crystal Park 2, Suite 1100 (FAX-308-5413)
Mary Louise McAskill, Crystal Park 3-910 (FAX 305-4372)
Niomi Farmer, Crystal Park 3-910 (FAX-305-4372)
Mary E. Johnson (Cookie), P/OCS, CM1-6D07
Duane K. Davis, P/OCS, CM1-6A07
Tamara K. Greene, PK3-910